INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 9, 2026

IGI Report Number	LG842624967
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	10.80 X 5.33 X 3.33 MM

GRADING RESULTS

Carat Weight	1.07 CARAT
Color Grade	E
Clarity Grade	VVS 2

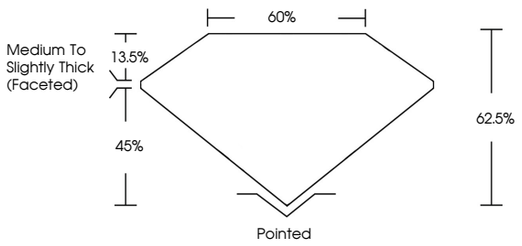
ADDITIONAL GRADING INFORMATION

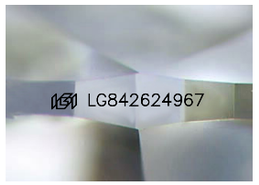
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG842624967

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG842624967
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

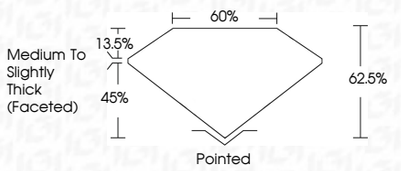
FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

October 9, 2026
IGI Report Number LG842624967
Description LABORATORY GROWN DIAMOND
Shape and Cutting Style MARQUISE BRILLIANT
Measurements 10.80 X 5.33 X 3.33 MM
GRADING RESULTS
Carat Weight 1.07 CARAT
Color Grade E
Clarity Grade VVS 2



ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG842624967
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 9, 2026
IGI Report No LG842624967
MARQUISE BRILLIANT
10.80 X 5.33 X 3.33 MM
Carat Weight 1.07 CARAT
Color Grade E
Clarity Grade VVS 2
Depth 62.5%
Table 60%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG842624967
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa